

“Method of Fabricating Multipole Lens, Multipole Lens, and  
Charged-Particle Beam Instrument Equipped Therewith”

Inventor: Eiji KAWAI

Attorney Docket No. 116-043660

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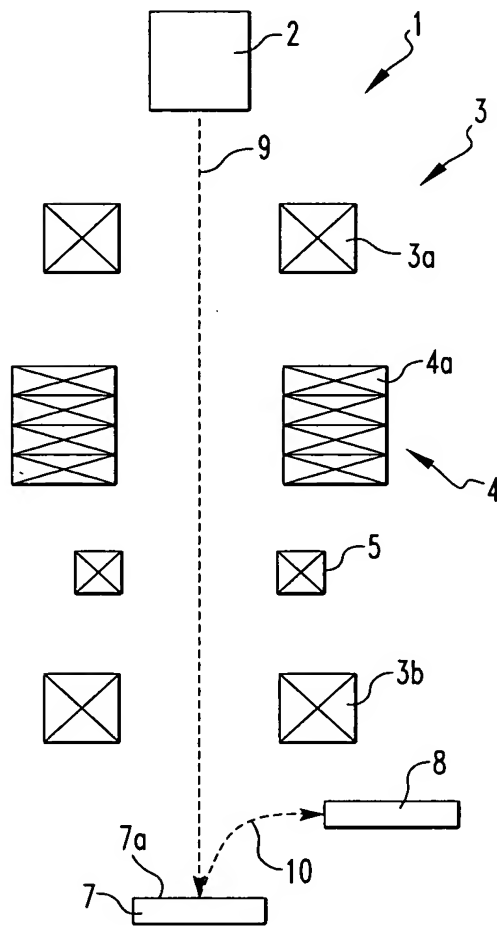
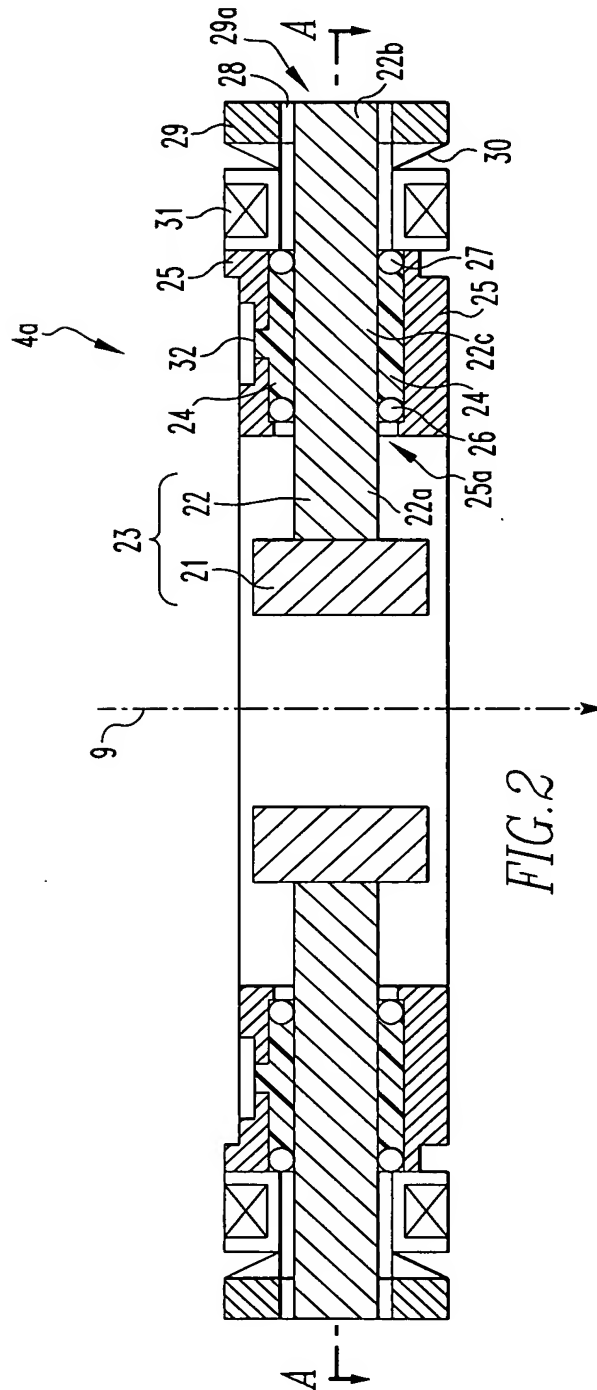


FIG. 1

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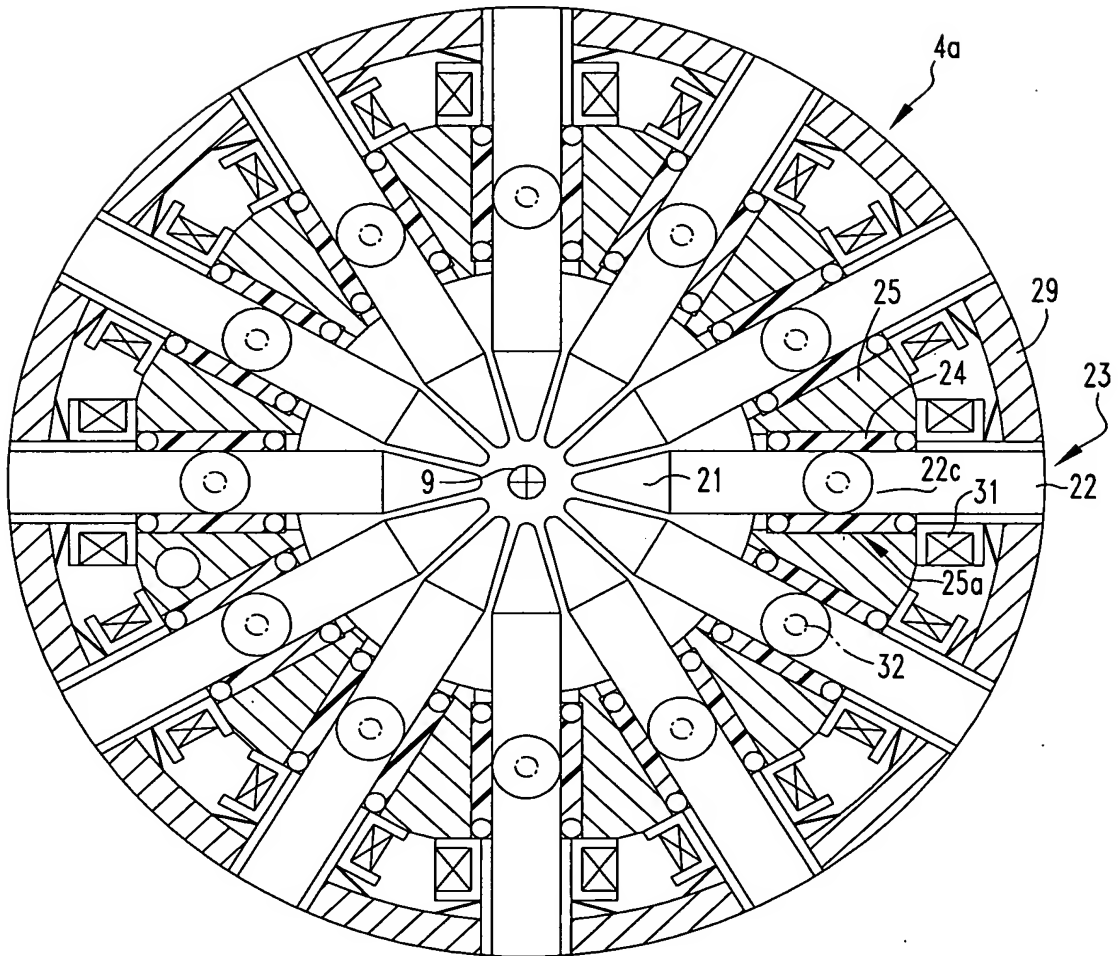


FIG. 3

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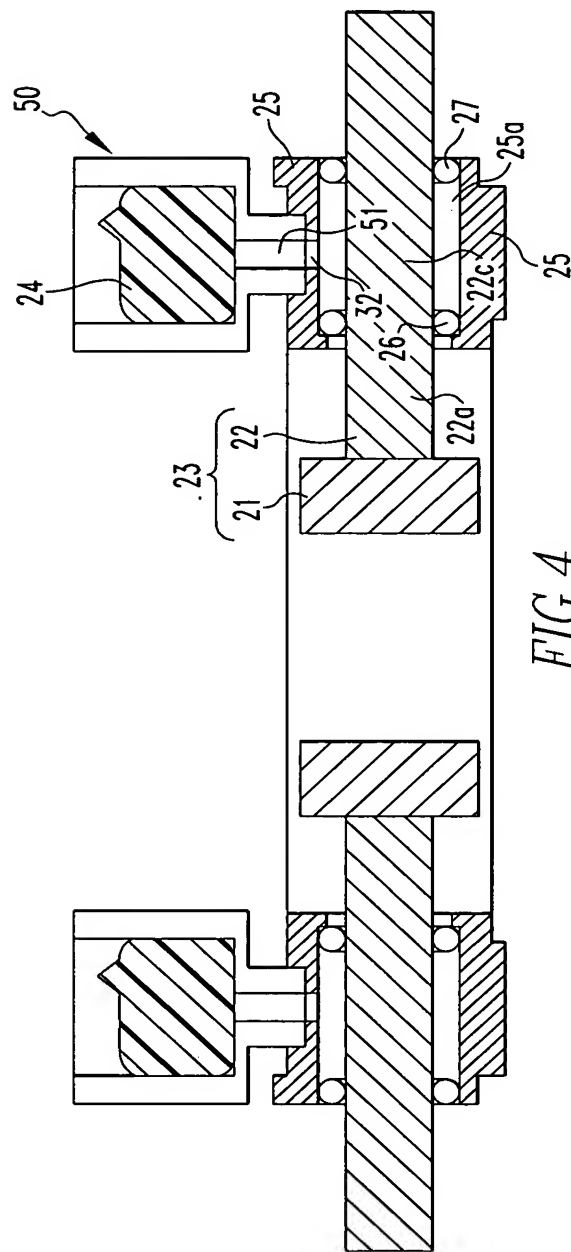


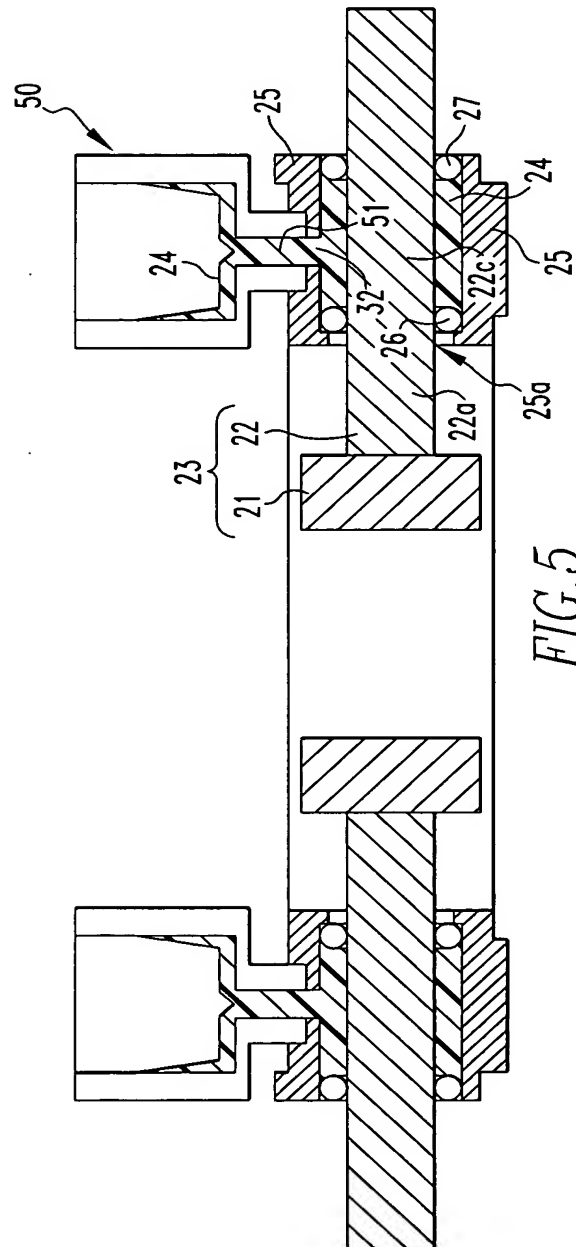
FIG. 4

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